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## BIB DATA SHEET

CONFIRMATION NO. 4981

<b>SERIAL NUMBER</b> 10/530,475	<b>FILING or 371(c) DATE</b> 04/06/2005 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2813	<b>ATTORNEY DOCKET NO.</b> 050179		
<b>APPLICANTS</b> Masahide Kawaraya, Hiratsuka-shi, JAPAN; Iwao Hayashi, Hiratsuka-shi, JAPAN; <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/13019 10/10/2003 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-297385 10/10/2002 JAPAN 2003075849 03/19/2003 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /COLLEEN E RODGERS/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 0	<b>TOTAL CLAIMS</b> 17	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> KRATZ, QUINTOS & HANSON, LLP 1420 K Street, N.W. Suite 400 WASHINGTON, DC 20005 UNITED STATES						
<b>TITLE</b> Method for forming semiconductor film and use of semiconductor film						
<b>FILING FEE RECEIVED</b> 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			